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ATTORNEY DOCKET NO.: 04329.2230

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

New U.S. Patent Application

Title: RESIN ENCAPSULATING APPARATUS AND METHOD USED IN A
MANUFACTURE OF A SEMICONDUCTOR DEVICE

Inventor: Kenji HASHIMOTO

Sir:

We enclose the following papers for filing in the United States Patent and
Trademark Office in connection with the above patent application.

1. A check for \$808 representing the \$768 filing fee and \$40 for recording the Assignment.
2. Application - 35 pages, including 4 independent claims and 20 claims total.
3. Drawings - 13 sheets of formal drawings containing 26 figures.
4. Declaration and Power of Attorney.
5. Recordation Form Cover Sheet and Assignment to Kabushiki Kaisha Toshiba.
6. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with 3 documents attached.

U.S. PTO
09/503170
02/14/00

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09503170-024400

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Applicant claims the right to priority based on Japanese Application No. 11-035464, filed February 15, 1999.

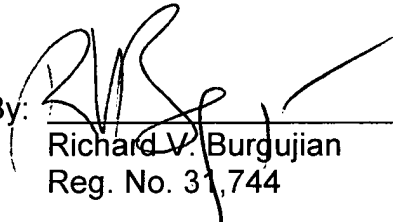
Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
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By:


Richard V. Burgujian
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RVB/FPD/dvz
Enclosures

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